

4

Light diffraction on grating

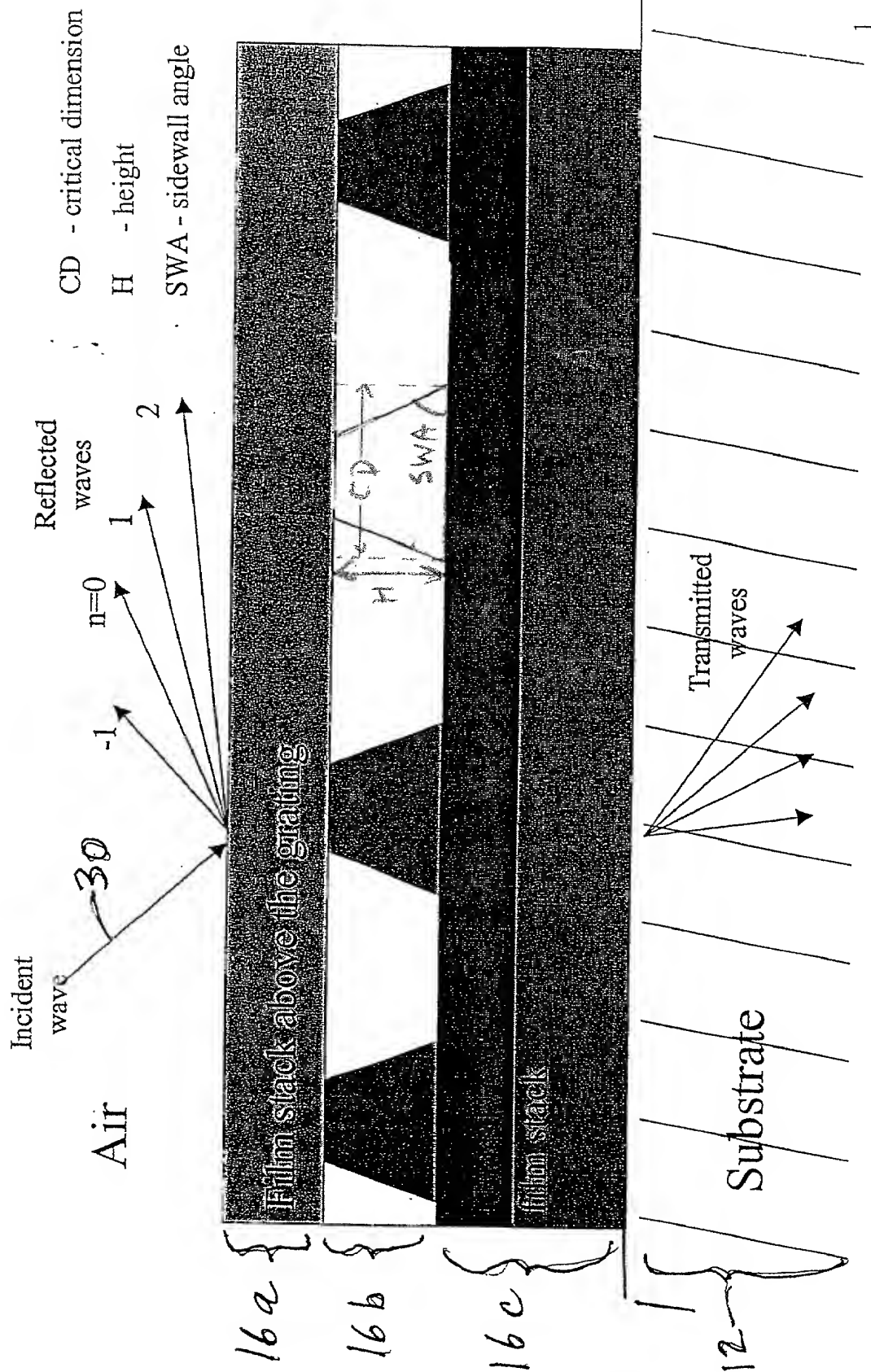


Fig. 1B

80 ✓

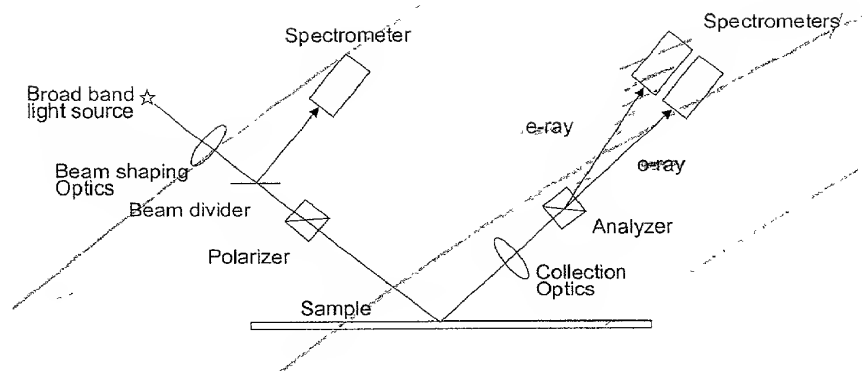


Figure 1

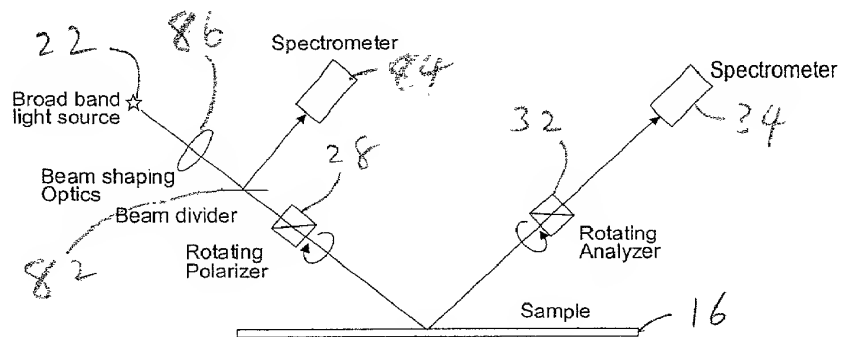


Figure 2. Ellipsometer or reflectometer with rotating polarizer and analyzer

Figure 3. Measured Structures (profile and film stack)

~~a.~~ Trapezoidal grating on top of a film stack

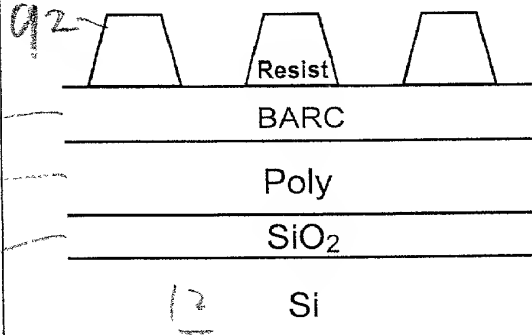
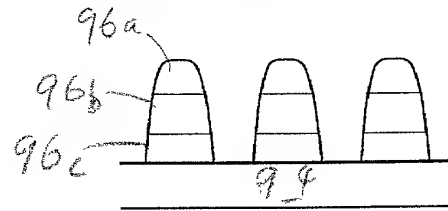
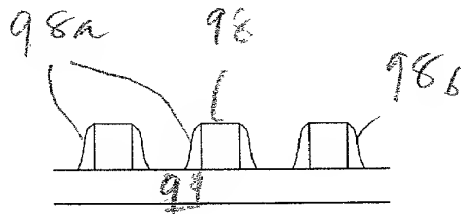


FIG. 3B

~~b.~~ Etched grating



~~c.~~ Grating with sidewall spacers



~~d.~~ Periodic structure with via holes

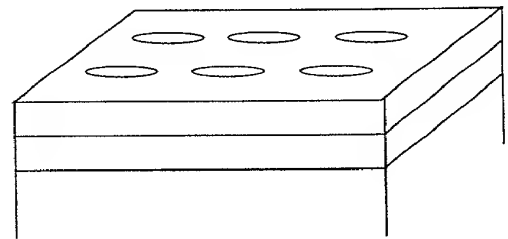


FIG. 3C

FIG. 3D

Figure 4. Sample Profile Models

FIG. 4 A

- a. Single material,
multi-trapezoid profile

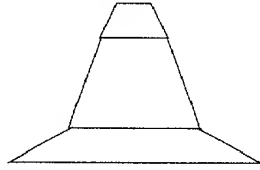


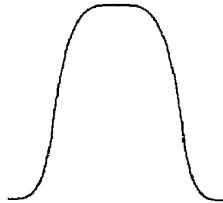
FIG. 4-B

- b. Single-material,
quartic profile



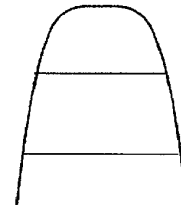
- c. Single-material quartic profile
with a bottom rounding

FIG. 4 C



- d. Multi-material etched profile
based on the quartic model

FIG. 4 D



- e. Two-material profile with
sidewall spacers

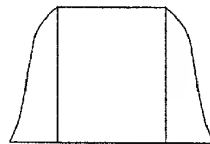


FIG. 4-E

- f. 3-dimensional via hole profile
— a hole in a uniform layer

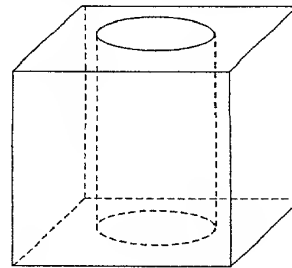


FIG. 4-F

Figure 5. Flowchart of profile and film measurement

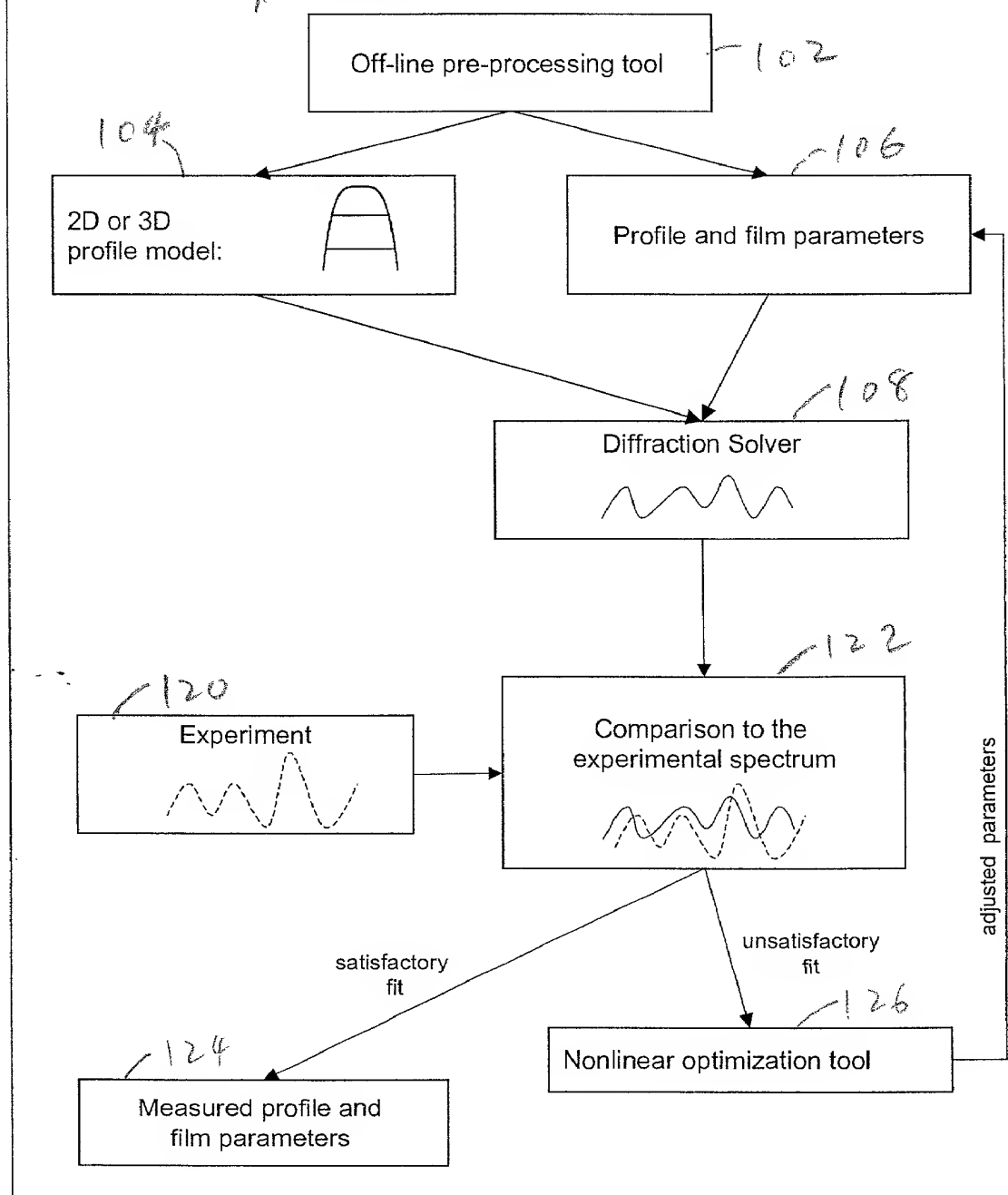


Figure 5a. Flowchart of Diffraction Solver

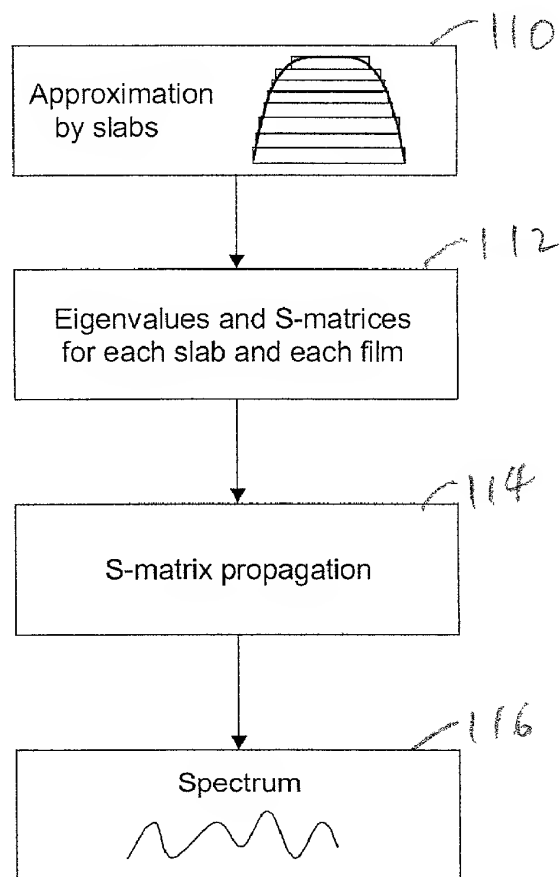
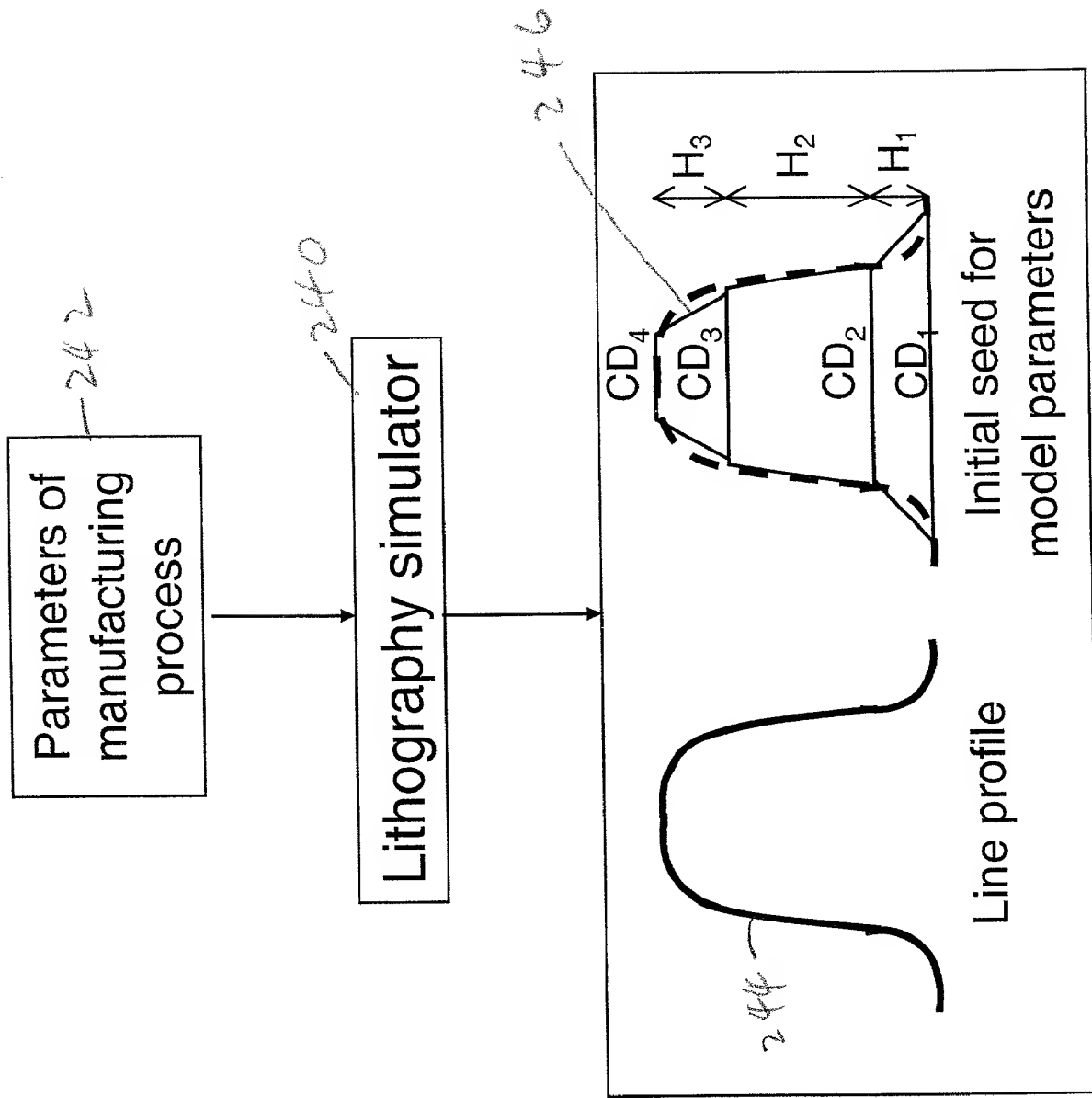
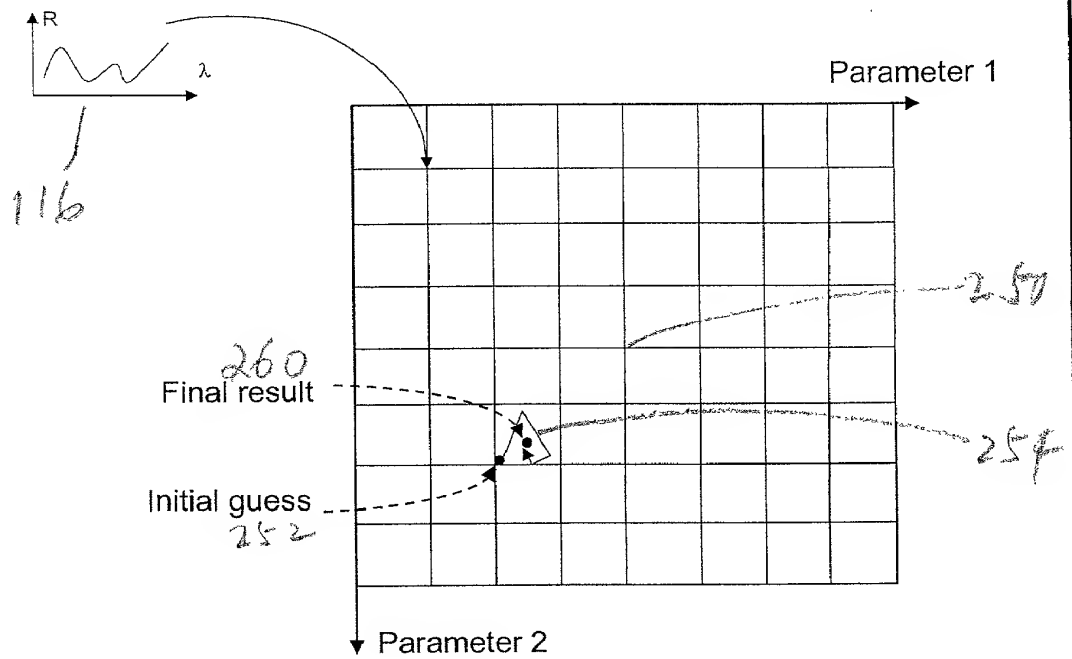


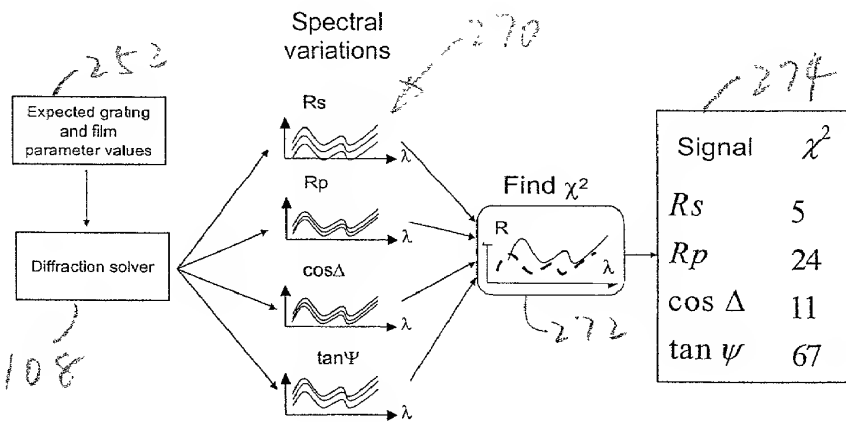
Figure 6a Selection of the optimal profile model and initial seed



68
Figure 6c. Selection of the starting point for nonlinear optimization from the coarse library



6C
Figure 6b. Selection of the optimal signal for matching



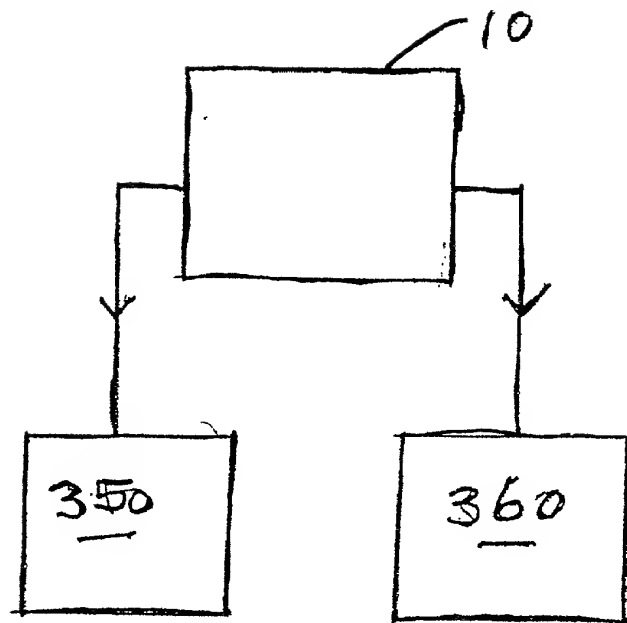
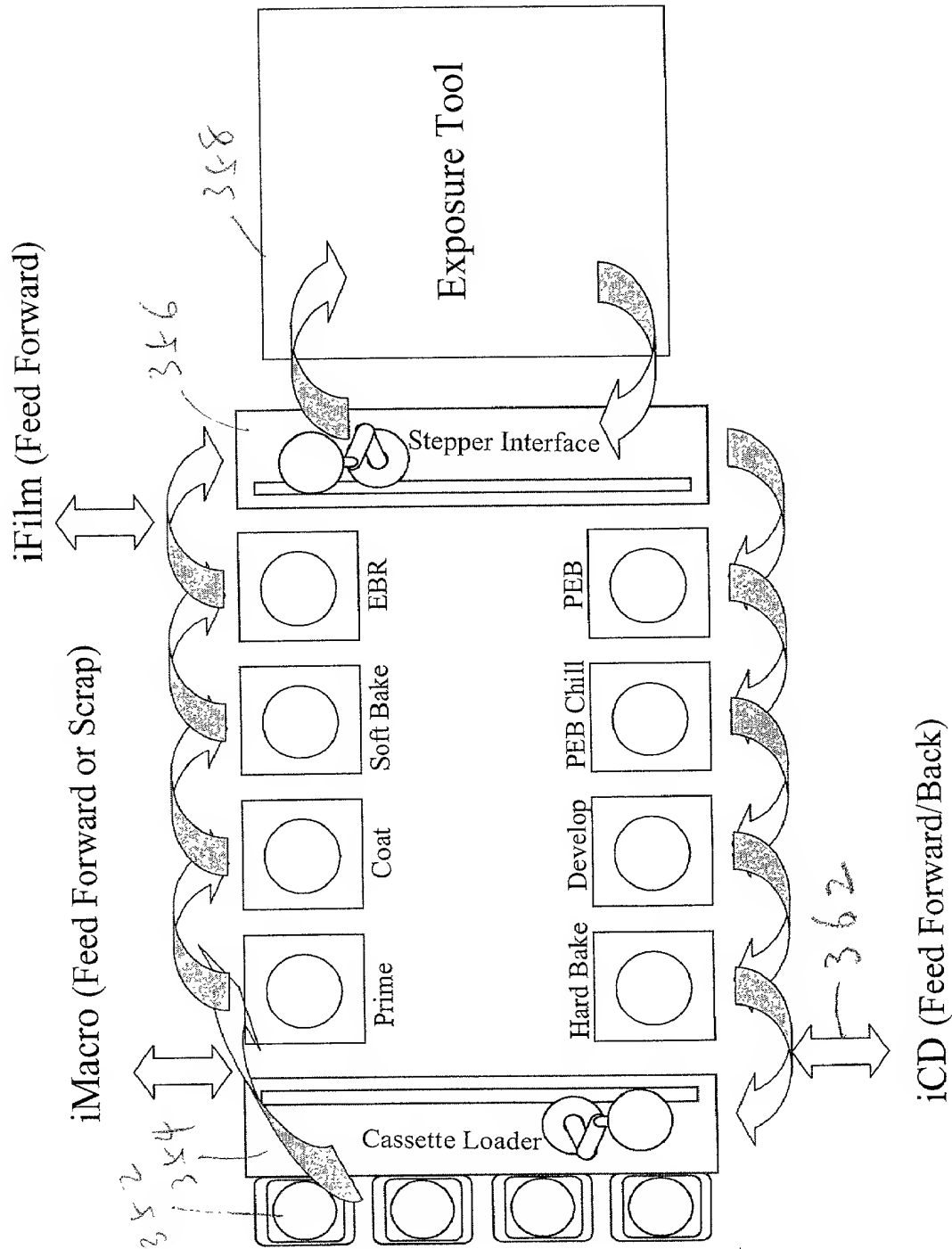


FIG. 127

350

Points of Integration



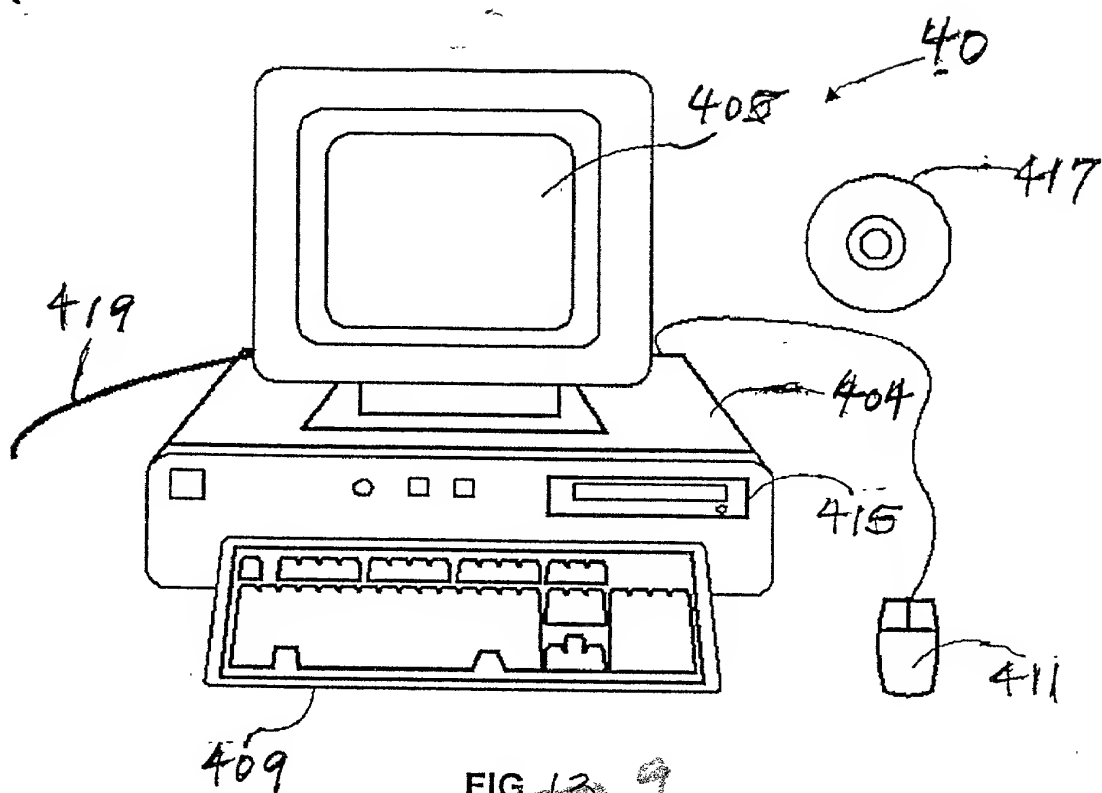


FIG 13. 9